# Model 82 UltraStable



316L SS Pressure Sensor
High Performance, 19 mm
0-100 mV Output
Absolute and Gage
Low Pressure



#### **FEATURES**

- O-Ring Flush Mount
- ► -20°C to +85°C Compensated Temperature Range
- ▶ ±0.1% Pressure Non-linearity
- ±1.0% Interchangeable Span (provided by gain set resistor)
- ▶ Solid State Reliability
- ▶ Low Power

#### STANDARD RANGES

Range	psig	psia
0 to 5	Contact I	Factory
0 to 15	•	•
0 to 30	•	•
0 to 50	•	•
0 to 100	•	•
0 to 300	•	•
0 to 500	•	•

- Hydraulic Controls
- Process Control
- Oceanography
- Refrigeration/Compressors
- Pressure Transmitters
- Level Systems

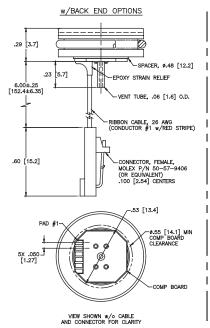
## **DESCRIPTION**

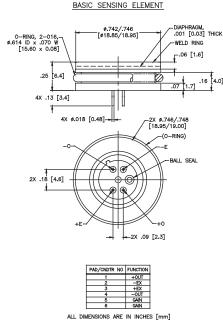
The Model 82 is a 19 mm small profile, media compatible, piezoresistive silicon pressure sensor packaged in a 316L stainless steel housing. The Model 82 is designed for O-ring mounting. The sensing package utilizes silicone oil to transfer pressure from the 316L stainless steel diaphragm to the sensing element.

The Model 82 is designed for high performance, low pressure applications. A ceramic substrate is attached to the package that contains laser-trimmed resistors for temperature compensation and offset correction. An additional laser-trimmed resistor is included which can be used to adjust an external differential amplifier and provide span interchangeability to within  $\pm 1\%$ .

Sensors with threaded pressure fittings, weldable flush sensors and high pressure stainless steel sensors are also available. Please contact the factory for more information.

### **DIMENSIONS**





### PERFORMANCE SPECIFICATIONS

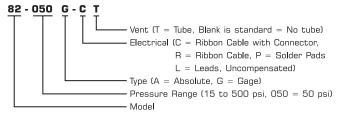
All parameters specified at 1.5mA and at 25°C, after 10 second warm up, unless otherwise indicated. Unless specifically indicated, only those parameters indicated as tested are verified on each part. Parameters are specified for the compensated version only.

PARAMETERS	MIN	TYP	MAX	UNITS	NOTES
Full Scale Output Span	75	100	150	mV	1
Zero Pressure Output (Offset)	-1	0	1	mV	2
Pressure Non Linearity	-0.10		0.10	±% Span	3
Pressure Hysteresis	-0.05	0.02	+0.05	±% Span	
Repeatability		0.02		±% Span	
Input Resistance	2000	3500	4500	Ω	
Output Resistance	4000		25000	Ω	
Temperature Error - Span (-20 to +85°C)	-0.75		+0.75	% Span	4
Temperature Error - Offset (-20 to +85°C)	-0.5		+0.5	% Span	4, 5
Thermal Hysteresis - Span		0.05		% Span	4
Thermal Hysteresis - Offset		0.05		% Span	4
Long Term Stability - Span		0.1		±% Span/year	
Long Term Stability - Offset		0.1		±% Span/year	
Supply Current	0.5	1.5	2.0	mA	6
Output Load Resistance	5			ΜΩ	7
Insulation Resistance (50 VDC)	50			ΜΩ	8
Pressure Overload			ЗХ	Rated	
Compensated Temperature Range	-20°C to +85°C	-20°C to +85°C			9
Operating Temperature Range	-40°C to +125°C	-40°C to +125°C			9
Storage Temperature Range	-50°C to +125°C	-50°C to +125°C			
Media - Pressure Port	Liquids and Gases	Liquids and Gases compatible with 316L Stainless Steel			
Media - Reference Port		Compatible with Silicon, Pyrex, Gold, Fluorosilicone Rubber and 316L Stainless Steel			
Weight	12 g	12 g			

#### Notes

- 1. For amplified output circuits see application note TN-003.
- 2. Measured at vacuum for absolute (A), ambient for gage (G).
- 3. Best fit straight line.
- 4. Over the temperature range  $-20^{\circ}\text{C}$  to  $+85^{\circ}\text{C}$  with respect to  $+25^{\circ}\text{C}$ .
- 5. 15 psi range sensors have an offset temperature error of  $\pm 0.75\%$  (Max) from  $-20^{\circ}\text{C}$  to  $+85^{\circ}\text{C}$ .
- 6. Guarantees output/input ratiometricity.
- 7. Load resistance to reduce measurement errors due to output loading.
- 8. Between case and sensing element.
- 9. Maximum temperature range for product with standard cable and connector is  $-20\,^{\circ}\text{C}$  to  $+105\,^{\circ}\text{C}$ .
- For gage units used at pressures below atmosphere, the span accuracy is not guaranteed.

# **ORDERING INFORMATION**

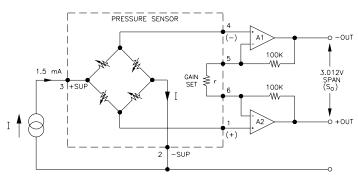


For other ranges, process fittings and electrical connections contact factory.

# CONNECTIONS

PAD/CONDUCTOR NO	FUNCTION
1	+OUT
2	-EX
3	+EX
4	-OUT
5	GAIN
6	GAIN

# **APPLICATION SCHEMATIC**



June 2001